



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor Werner Juengling
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Brook Kebede
Attorney's Docket No. MI22-2391
Customer No. 021567
Title: Semiconductor Processing Methods of Forming a Contact Opening to a
Conductive Line and Methods of Forming Substrate Active Area
Source/Drain Regions .


SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the references listed on the attached Form PTO-1449. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether the submitted references are prior art.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 10-26-06

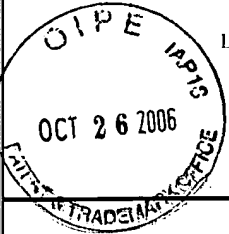
By: 
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Form PTO-1449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2391		SERIAL NO. 10/678,513	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)							
APPLICANT Werner Juengling						FILING DATE October 3, 2003	
GROUP 2823							
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	6,949,430	09/2005	Juengling				
AB							
AC							
AD							
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AH							
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AM							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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